

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Akira HORIGUCHI *et al.*

Serial No.: 09/743,502

Filing Date: June 7, 2001

For: DOUBLE SIDE POLISHING METHOD AND
APPARATUS (as amended)

Examiner: Eileen P. Morgan

Art Unit: 3723

Confirmation No.: 4060

AMENDMENT UNDER 37 CFR 1.111

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Action mailed May 12, 2009, please amend this application as follows:

The amendment to the specification begins on page 2.

The listing of claims begins on page 3.

The Remarks begin on page 10.